

Application Serial No. 10/594,174
Response to Office Action dated February 18, 2009

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PATENT
Docket: CU-5102

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR: Hideshi Hattori et al.)
APPLICANT: Dai Nippon Printing Co., Ltd) EXAMINER: Kosson, Rosanne
SERIAL NO: 10/594,174)
FILED: 09/26/2006) GROUP ART UNIT: 1652
TITLE: METHOD FOR PRODUCING CELL CULTURE SUBSTRATE AND
APPARATUS FOR PRODUCING CELL CULTURE SUBSTRATE
Attorney CU-5102
Docket No.

Mail Stop Amendment
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

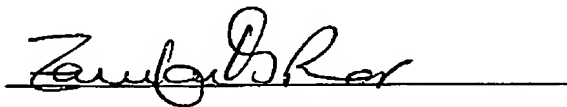
REQUEST FOR 3-MONTH EXTENSION OF TIME

Dear Sir:

With reference to the office action dated February 18, 2009 the applicants hereby request a three-month extension of the term for response, which thereby extends the end date of the current term from May 18, 2009 to August 18, 2009.

Please charge \$1110.00 to Deposit Account No. 12-0400 to cover the cost of the extension. No other fee is believed to be required. However, if this is not the case, please charge any additional fee or credit any overpayment to the same Deposit Account No. 12-0400.

Respectfully submitted,



Zareefa B. Flener, Pat. Reg. No. 52,896

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